



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

May 12, 2026	
IGI Report Number	LG800646855
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUSHION MODIFIED BRILLIANT
Measurements	9.69 X 7.06 X 4.69 MM

GRADING RESULTS

Carat Weight	2.51 CARATS
Color Grade	D
Clarity Grade	VS 1

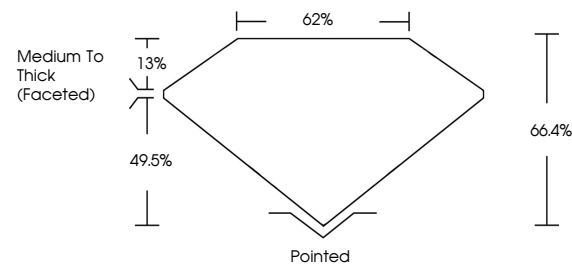
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG800646855

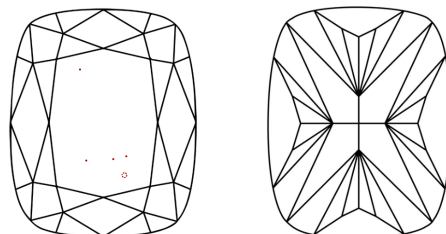
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG800646855
Report verification at igi.org

PROPORTIONS

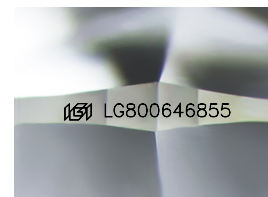


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

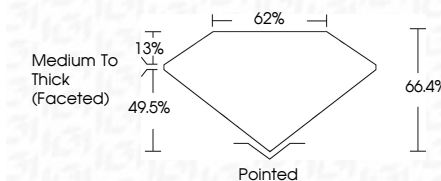
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

	May 19, 2026
	GI Report No LG80044985
	CUSHION MODIFIED BRILLIANT
	2.51 CARATS
	D
	VSI
	66.4%
	62%
	Medium to Thick (Faceted)
	Poited
	EXCELLENT
	EXCELLENT
	NONE
	#G1 LG80044985
	Comments:
	This is a Heavy Crown Diamond was
	analyzed by Chemical Vapor Deposition
	(CVD) growth process.
	Type IIA